

## Announcement for the position of Associate Professorship

**1. Position title:** Associate Professor of Laboratory for Materials and Structures, Institute of Innovative Research

**2. Research field:** Surface science towards creation of new functions  
Development of new functions of materials based on surface science analysis methods.

**3. Minimum qualification:** Applicants must have a Ph.D. degree and ability to supervise graduate students.

**4. Expected start date:** April 1st, 2017.

**5. Term of office:** 5 years, a possible maximum 5-years reappointment.

**Salary:** Annual salary will be paid according to the National University Corporation Tokyo Institute of Technology Regulations on Wage and Salary for Staff on the Annual Salary System.

**6. Affiliation:** Laboratory for Materials and Structures, Institute of Innovative Research.

### **7. Documents to be submitted:**

1) Curriculum vitae (with photograph, telephone number, e-mail and mailing addresses) including academic background, professional carrier after high school, applicant's ResearcherID, and library-name of Google Scholar's profile.

2) Summary of major research achievements to date (A4 paper; 2 pages or less).

3) List of research achievements categorized into the following types: a) refereed original articles, b) reviews and commentaries, c) books, d) patents.

All authors in the same order as each publication should be clarified. Five representative papers should be marked the symbol of \*.

4) Reprints or copies of five significant papers.

5) Explanation of the academic significance and importance of the five representative papers (A4 or letter size, upto two pages totally).

6) List of awards received, invited or keynote lectures of international meetings and grants.

7) List of acquired research and educational funds (fund name, project title, budget, and period of research or education project). Specify whether the applicant is

the principal investigator or a co-investigator and the total and allotted budgets in the case of a co-investigator for each fund. Social activity records including activities in academic societies, and the list of awards.

- 8) Research and educational policy after taking this position (A4 paper; 2 pages or less)
- 9) List of the names and contact information (affiliation, address, and e-mail address) for two persons who can evaluate your work.

**8. Deadline:** October 21st, 2016

**9. Mailing Address for applications:**

Office of Laboratory for Materials and Structures, Tokyo Institute of Technology,  
R3-28, 4259 Nagatsuta-cho, Midori-ku, Yokohama 226-8503, JAPAN

Applicants should send the application documents to the above address by a registered mail, with "Application for Associate Professor" written in red on the envelope. Note that the documents will not be returned. Submitted documents are strictly protected under the Privacy Policy of Tokyo Institute of Technology and will be used only for the purpose of applicant screening.

Personal information will not be disclosed, transferred or loaned to a third party under any circumstances without legitimate reasons.

**10. Inquiries:** Prof. Michikazu Hara,

e-mail: [mhara@mssl.titech.ac.jp](mailto:mhara@mssl.titech.ac.jp)

Notes:

- 1) All application documents must be submitted as PDF files on USB memory together with the printouts of the curriculum vitae and the list of publications. We do not accept the application by e-mail or internet file attachment.
- 2) Applicants have to bear their travel expenses to attend the interview.
- 3) Tokyo Institute of Technology provides start-up funding through an internal supporting system, and successful applicant may have access to such system.
- 4) Tokyo Institute of Technology, in order to ensure a diverse workforce, guarantees equal opportunities for all individuals regardless of nationality or gender.